



NIP-214

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

T. SEKI et al

Serial No. 09/756,922

Group Art Unit: 2881

Filed: January 10, 2001

Examiner: B. Anderson

For: ION IMPLANTATION EQUIPMENT AND  
IMPLANTATION METHOD THEREOF

AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 25, 2002,  
please amend the above-identified application as follows. A  
Petition and fee for a one-month Extension of Time accompanies  
this response.

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